



APPLICATION DATA SHEET

Electronic Version 0.0.11

Stylesheet Version: 1.0

Attorney Docket Number: 740756-2678

Publication Filing Type: new-utility

Application Type: utility

Title of Invention: MANUFACTURING METHOD FOR SEMICONDUCTOR DEVICE

Legal Representative:

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22204

Foreign Priority:

2002-366618

JP 2002-12-18

Priority Claimed

Assignee (Publish): Semiconductor Energy Laboratory Co., Ltd.

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